Atty. Ref.:HSJ9-2003-0126US1 (60717-341701)

Page 1 of 11

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: BEDELL, Daniel Wayne Atty Ref.: HSJ92003-0126US1 (60717.341701)

FOR (TITLE): ION MILL PROCESS WITH SACRIFICIAL MASK LAYER TO FABRICATE POLE TIP FOR PERPENDICULAR RECORDING

Filing Date: 09/30/2003 Examiner: TUGBANG, Anthony D.

Serial No: 10/676,728 Art Unit: 3729

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Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION

Dear Examiner Tugbang:

In response to the Office Action dated 07/06/2007, Applicant submits the following remarks and amendments, currently due on a statutory period for response expiring on 10/06/2007, which is a Saturday. This response is being filed electronically on the following Monday, 10/08/2007. It is thought that no extension of time is necessary.

The Examiner has stated, on the Office Action Summary that Claims 1-14 are pending, Claims 11, 12 and 14 are withdrawn from consideration and Claims 1-10 and 13 are rejected. This response is organized as follows:

Amendments to Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.

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